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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				ATTY DOCKET NO. 536-009.027		SERIAL NO. To be assigned			
				APPLICANT: Holger RUCKER et al.					
				FILING DATE: Herewith		ART UNIT: To be assigned			
UNITED STATES PATENT DOCUMENTS									
EXAM. INITIAL		DOCUMENT NUMBER	DATE	INVENTOR/ASSIGNEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	US	2002/0117733	Aug. 29, 2002	Michael Farjami, Esq.			Racaneli		
	US	6,642,553	Nov. 4, 2003	Juergen Drews et al.					
	US	2003/0189239	Oct. 9, 2003	Alexander Kalnitsky et al.					
	US	5,523,606	Jun. 4, 1996	Toru Yamazaki					
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FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO		
	EP	0 418 185 A1	Jul. 31, 1990	EP					
	EP	1 128 422 A1	Aug. 29, 2001	EP					
	EP	0 949 665 A2	Apr. 7, 1999	EP					
OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)									
		H.J. Osten et al., <i>The Effect of Carbon Incorporation on SiGe Heterobipolar Transistor Performance and Process Margin</i> ; IEEE 1997 0-7803-4100 (pages 32.4.1 - 32.4.4).							
Examiner (To be assigned)				Date: 10/20/2009					

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.P./